

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al. Art Unit : 2815
Serial No. : 09/379,702 Examiner : Eugene Lee
Filed : August 24, 1999 Conf. No. : 1613
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR ORAL HEARING

Under the provisions of 37 CFR §41.47(b), appellant respectfully requests an oral hearing. The fee in the amount of \$1000 in payment of the oral hearing request fee of \$1.17(p) is being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: Sept. 6, 2006

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